



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#9

Application Serial No. 09/705,101
Filing Date November 2, 2000
Inventor Vladimir M. Segal et al.
Assignee Honeywell International Inc.
Group Art Unit 1742
Examiner Wessman, Andrew E.
Attorney's Docket No. 30-5076(4015)
Title: Physical Vapor Deposition Targets, and Methods of Fabricating Metallic Materials

INFORMATION DISCLOSURE STATEMENT

References -- See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art. The Examiner is requested to make these citations of official record in this application.

The attached U.S. and foreign patents were cited in the International Search Report dated August 23, 2002 received in the related PCT Application, PCT/US01/51010, and are now being submitted in this Information Disclosure Statement. However, in the event that a fee is required for filing this Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Respectfully submitted,

Date: December 11, 2002

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